

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Hong-Gun Kim, et al.
Application No.: 10/732,931
Filed: December 11, 2003

Confirmation No.: 7254
Group Art Unit: 1765
Examiner: Patricia Ann George

For: **METHODS OF FILLING GAPS BY DEPOSITION ON MATERIALS
HAVING DIFFERENT DEPOSITION RATES**

July 3, 2007

MS AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

This response is submitted in reply to the Official Action mailed April 3, 2007. If any extension of time for the accompanying response or submission is required, Applicants request that this be considered a petition therefor. The Commissioner is hereby authorized to charge any additional fee, which may be required, or credit any refund, to our Deposit Account No. 50-0220.

REMARKS

Applicants appreciate the detailed examination evidenced by the Official Action mailed April 3, 2007 (hereinafter the *Official Action*). In response, Applicants respectfully point out several shortcomings in Knorr as well as several reasons why Knorr and Chen teach away from a combination with one another. Accordingly, Applicants respectfully request the withdrawal of all rejections and the allowance of all claims for at least the reasons described herein.

Independent Claim 9 is patentable over Knorr and Chen

Claims 4, 9, 10, 11, 12, 15 and 16 stand rejected under § 103 over U.S. Patent No. 6,531,377 to Knorr, et al. ("Knorr") in view of U.S. Patent No. 6,265,269 to Chen, et al. ("Chen"). *The Official Action*, page 2. In response, Applicants respectfully maintain that the cited references do not disclose or suggest